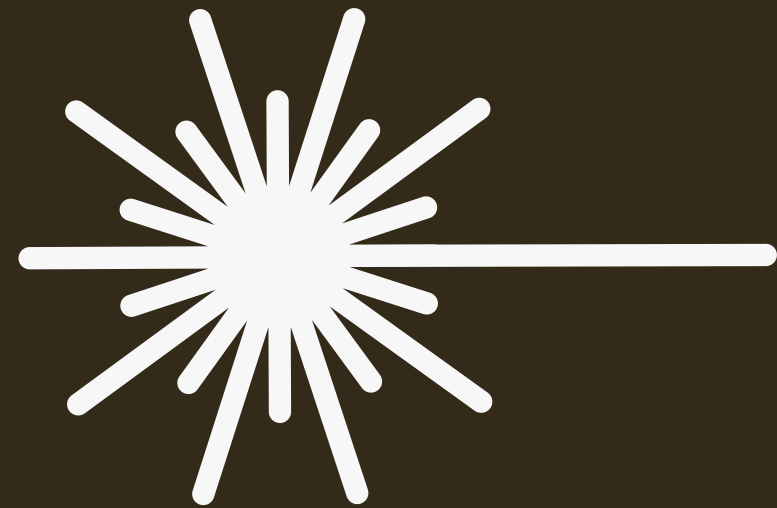
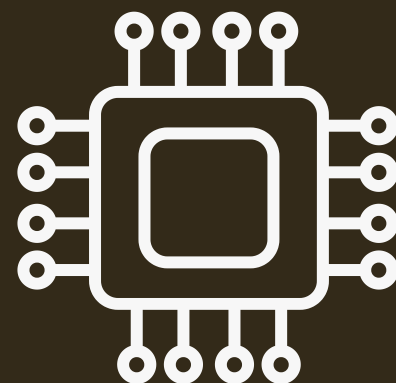
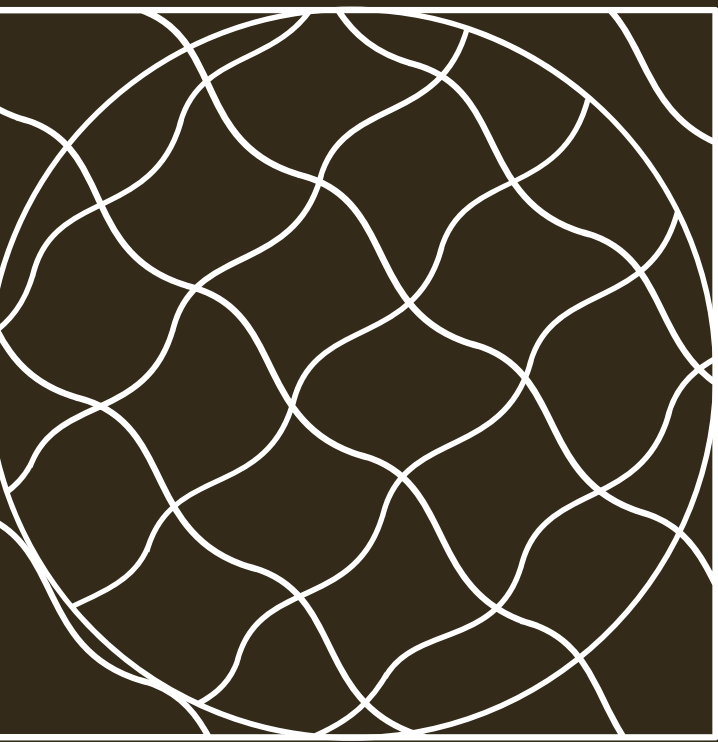


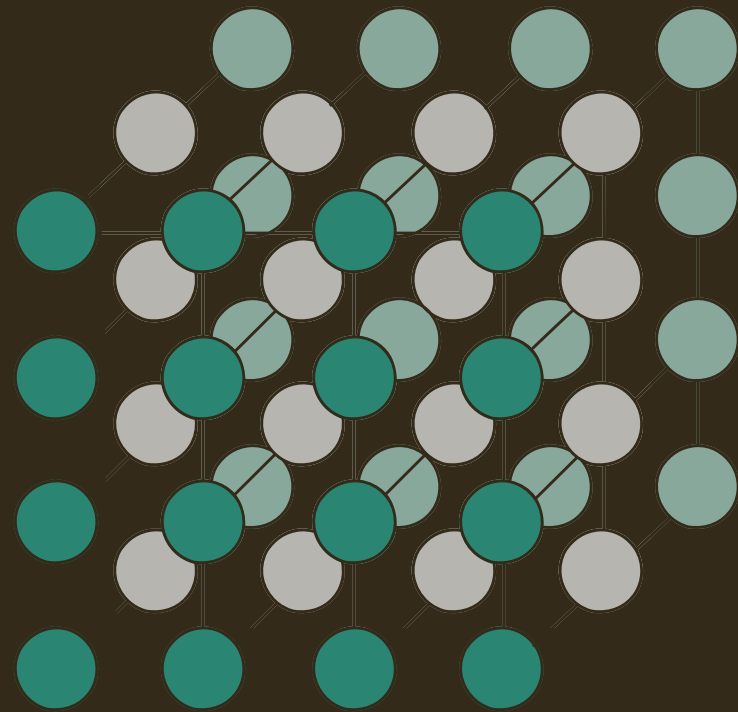
Reconfigurable Second Harmonic Generation (SHG) in Si_3N_4

Photonics Integrated Circuits

B. E. Castiblanco



OUTLINE



1. Motivation: Why induce χ^2 in Si₃N₄

2. Design

3. Mode simulations

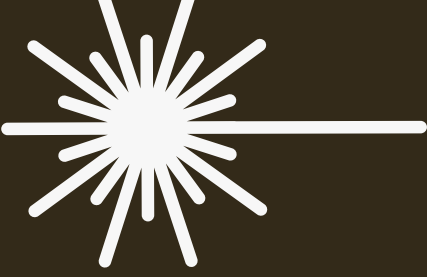
4. Temperature tuning and double-resonance hotspots

5. Effect of All-Optical-Poling (AOP):
hotspot expansion and χ^2 growth

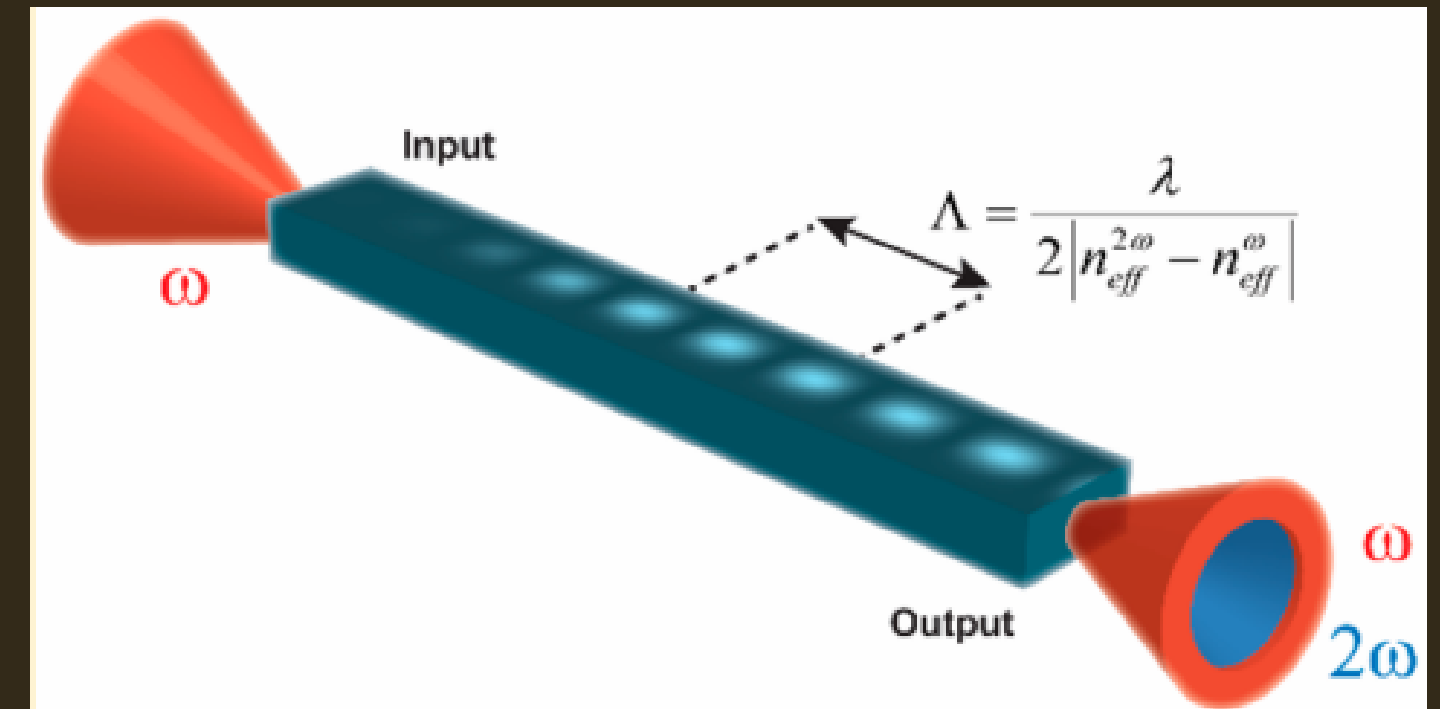
6. SHG performance

7. Outcomes, limitations, and conclusions

MOTIVATION: WHY INDUCE χ^2 IN Si_3N_4



- Silicon nitride is CMOS-compatible
- But SiN is centrosymmetric \rightarrow no $\chi(2)$
- All-optical poling (AOP) can induce $\chi(2)$ inside SiN using only light [1,2]
- Why $\chi(2)$ instead of relying on $\chi(3)$?



Taken from [2]

- \rightarrow SHG is much more efficient
- \rightarrow Generates 2ω (visible): applications to metrology and sensing applications
- \rightarrow THG requires more optical power

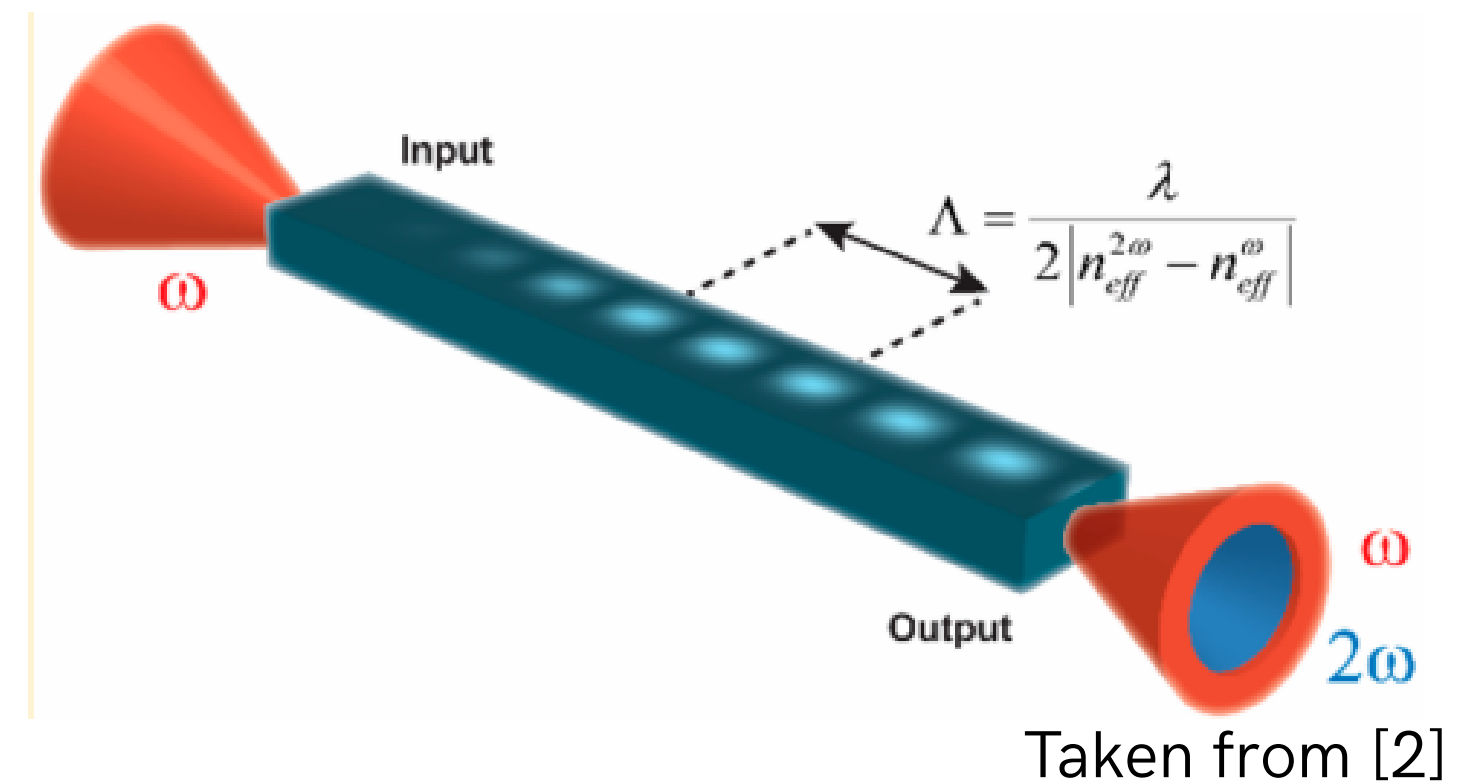
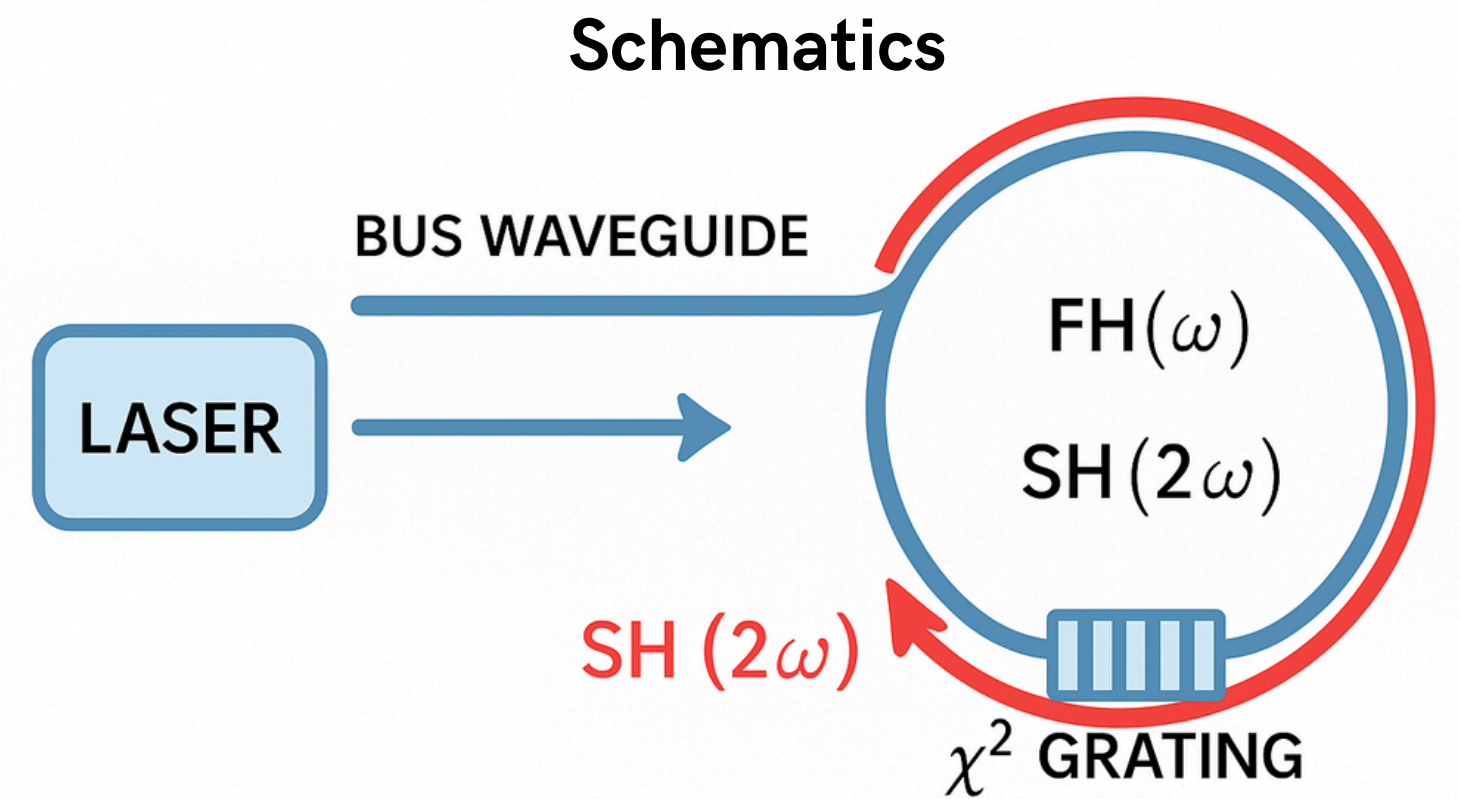
[1] Dianov & Starodubov 1995, Quantum Electron

[2] Nitiss et al. 2019, ACS Photonics

DESIGN

- Si_3N_4 microring ($R = 900 \mu\text{m}$) supports FH (ω) and SH (2ω) modes [3]
- Pump laser self-injection locks (SIL) to the FH resonance
- FH and SH circulating together \rightarrow AOP writes $\chi(2)$ grating
- $\chi(2)$ grating provides Quasi-Phase Matching (QPM) \rightarrow enhances SHG

[3] Clementi et al. (2023). Chip-scale SHG via self-injection-locked all-optical poling. Light: Sci. Appl..



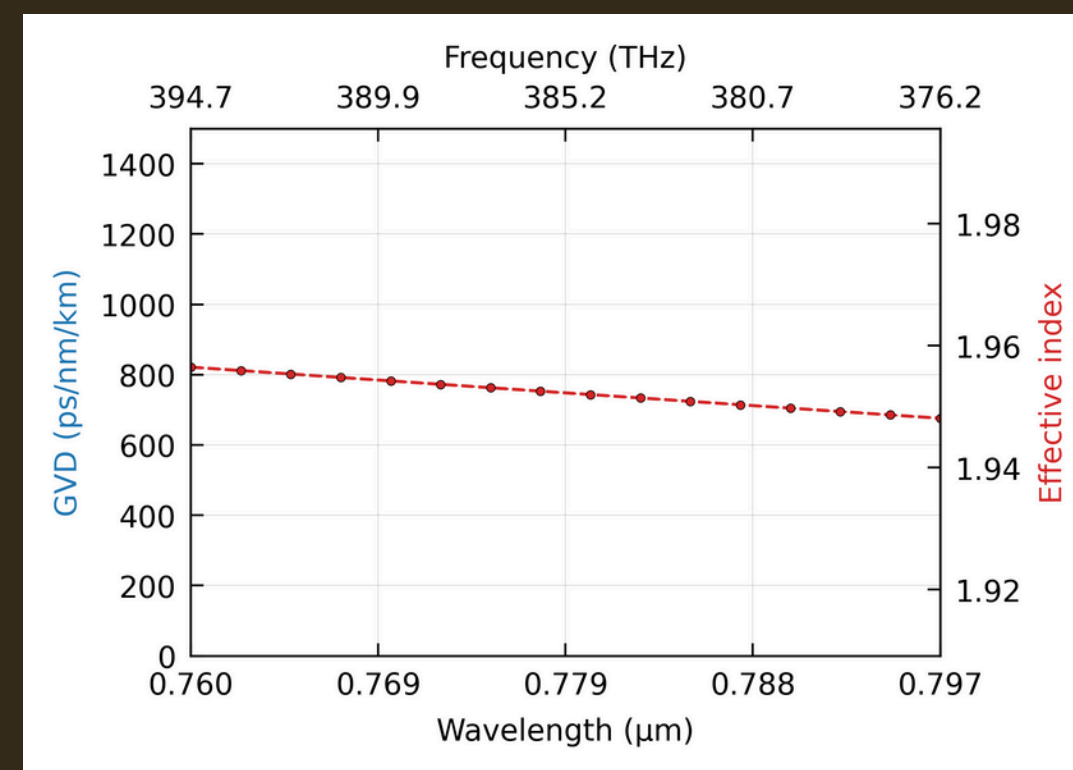
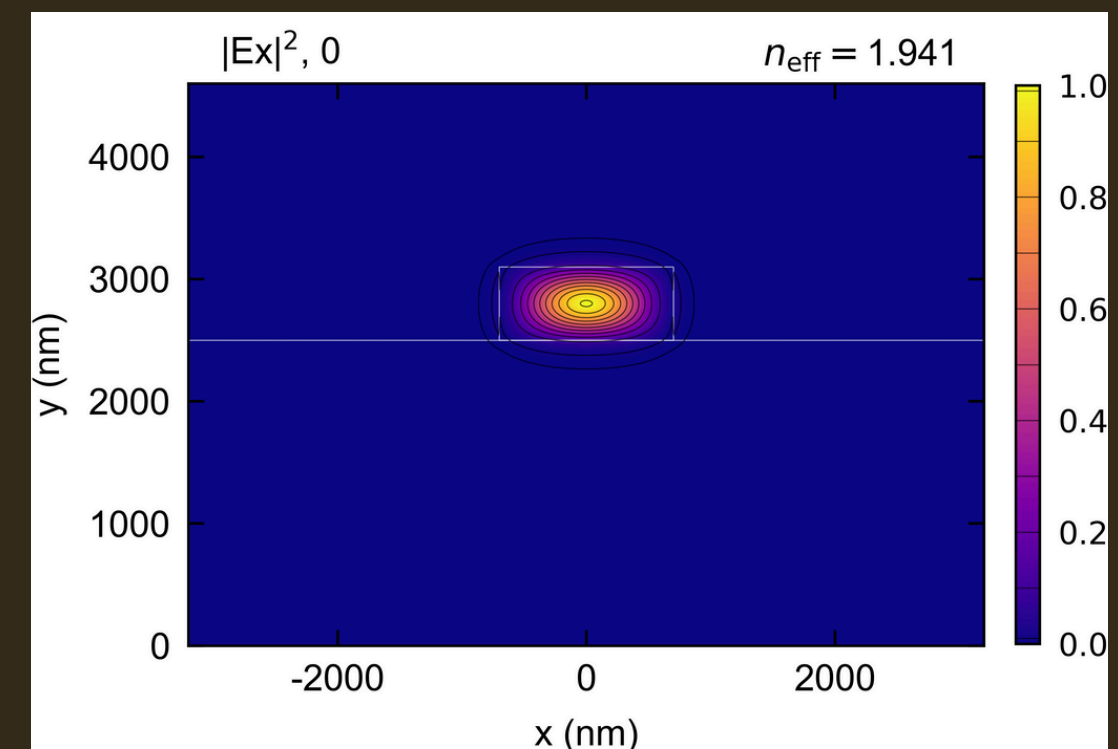
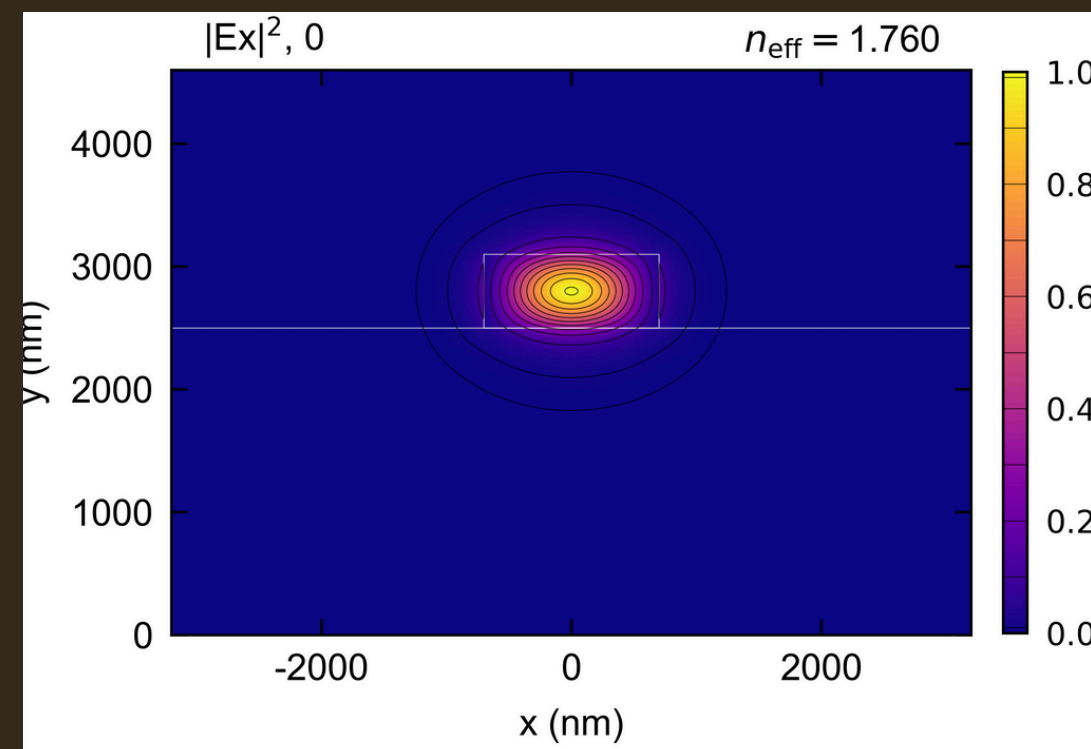
[2] Nitiss et al. 2019, ACS Photonics

MODE SIMULATIONS

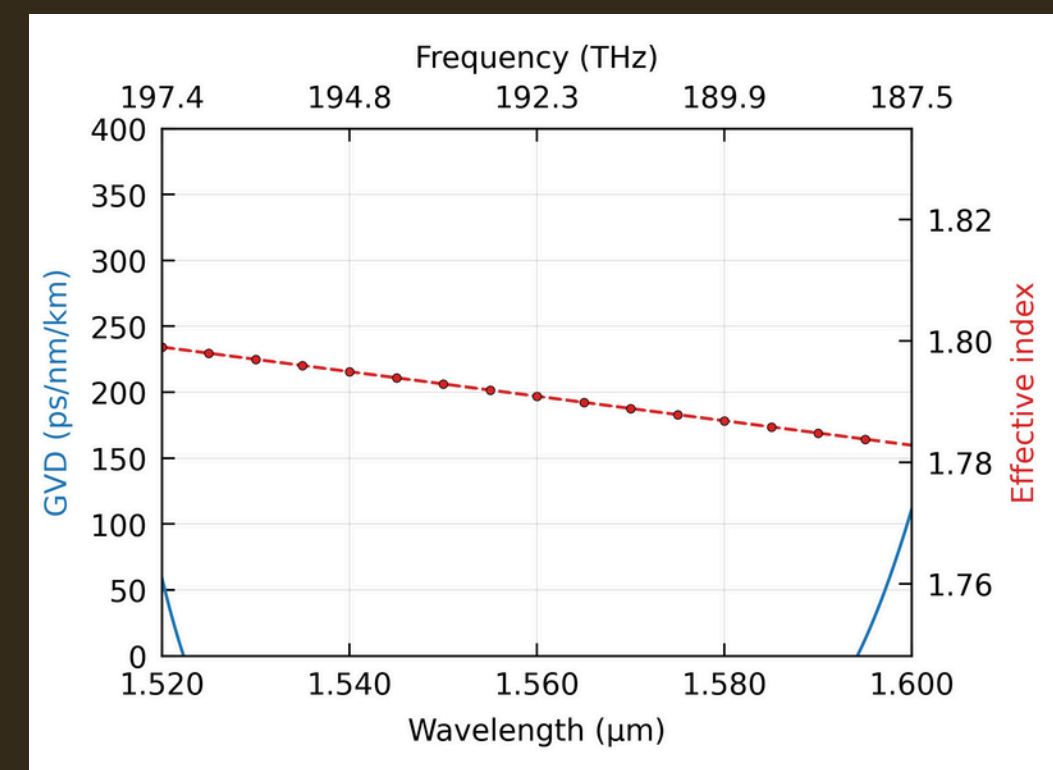
- Fully buried (silica) Si_3N_4
- Sweep in wavelength (C-L bands):
FH: 1520-1600 nm
SH: 760-800 nm
(approx linear disperssion/no $\chi(2)$)

- Extract $n_{\text{eff}}(\lambda)$
- Sweep in core width (0.8-1.6 μm)
- Straight waveguide approach:

$R = 900 \mu\text{m} \gg \text{core width} \sim 1 \mu\text{m}$



FH mode

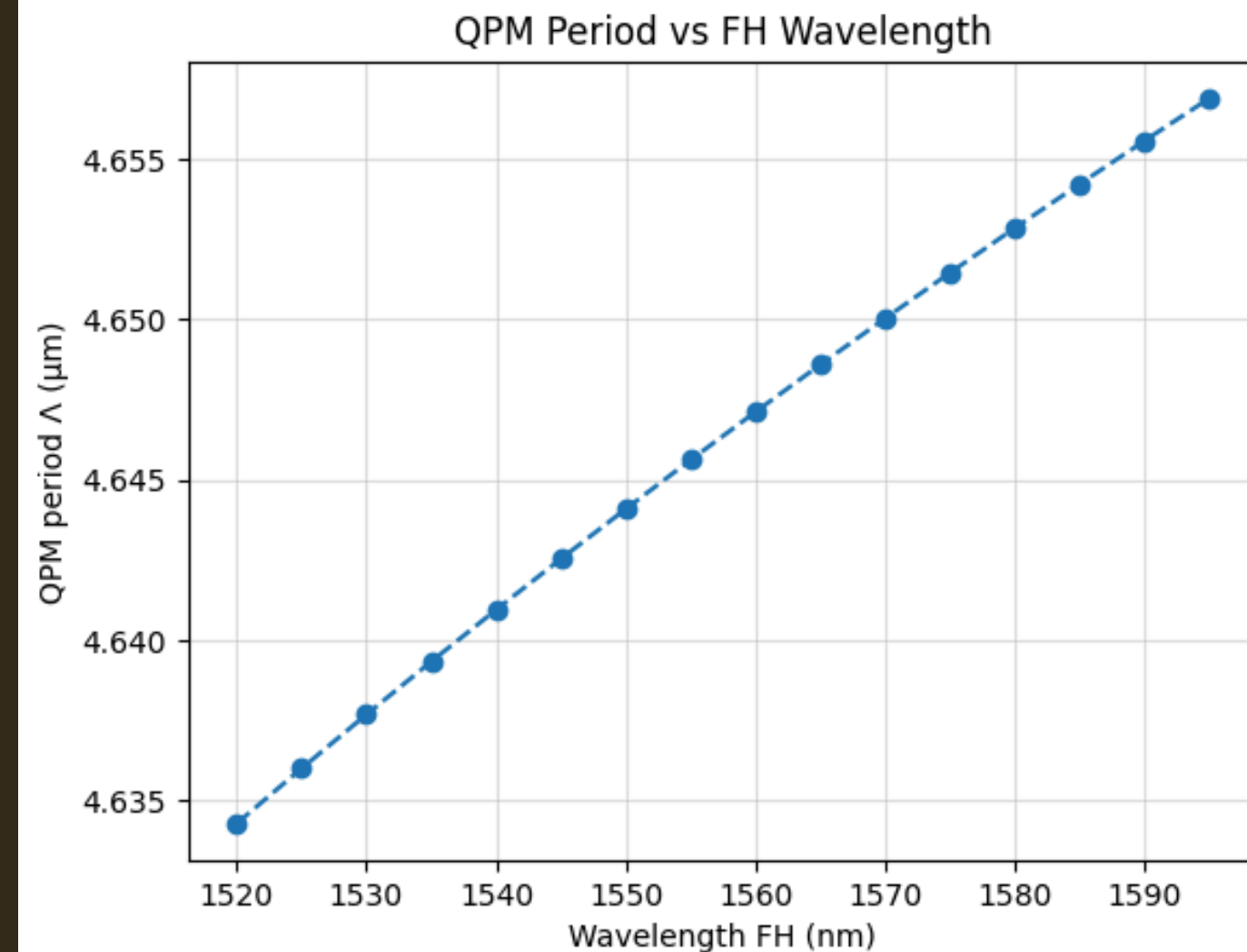
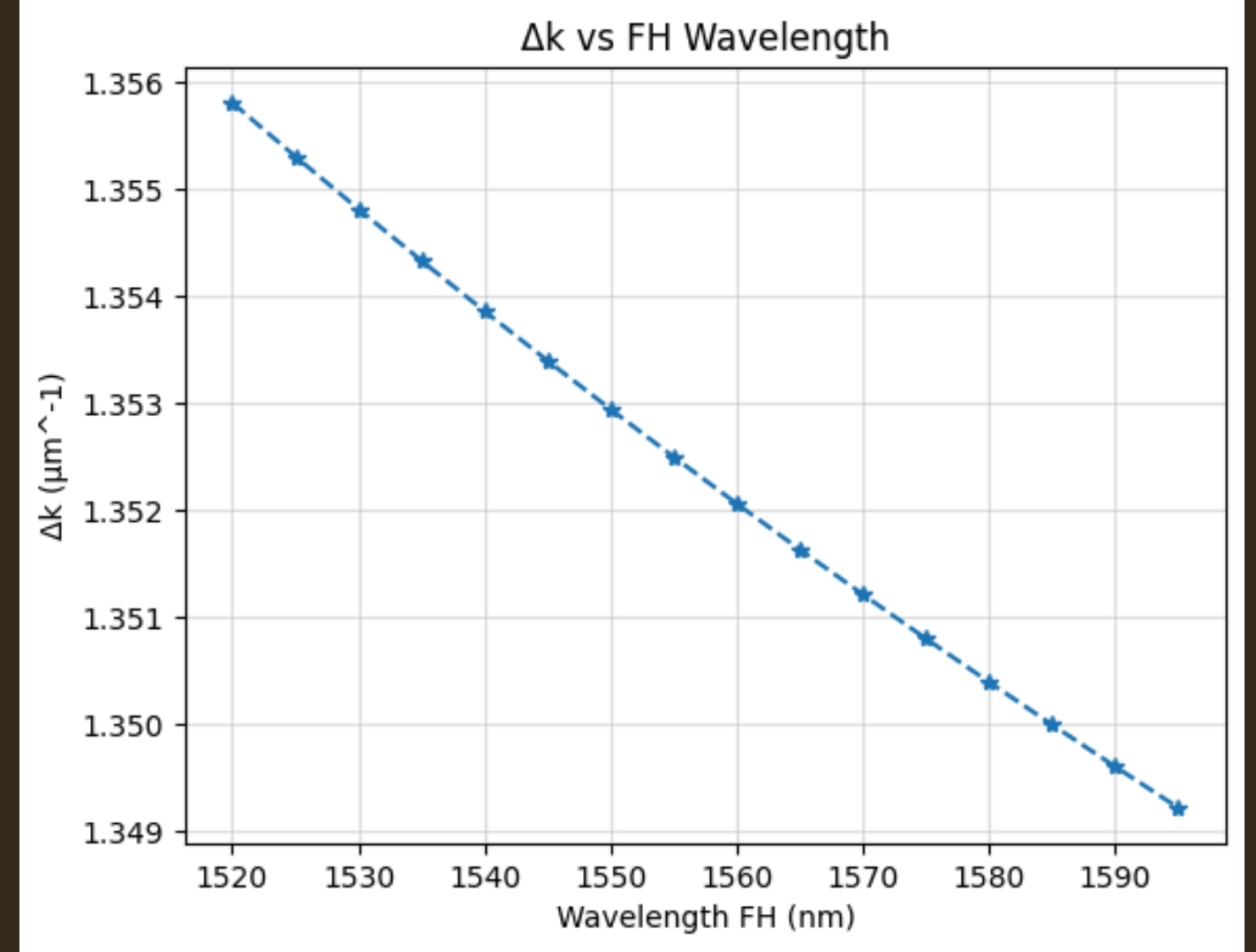


SH mode

MODE SIMULATIONS

- Δk varies smoothly with $\lambda \rightarrow$ QPM period Λ shifts linearly.
- $\Lambda \approx 4.64\text{--}4.66\text{ }\mu\text{m}$ for this Si_3N_4 geometry (consistent with [3]).
- Small Δk change \rightarrow sensitive to dispersion and thermo-optic tuning.

Now, by combining $\Delta k(\lambda)$ with thermal tuning, is possible to map the double-resonance hotspots.



EFFECT OF ALL-OPTICAL-POLING (AOP): HOTSPOT EXPANSION AND χ^2 GROWTH

All-Optical-Poling (AOP):

- Space-charge field grows via photogalvanic effect [1]:
- Feed χ^2 into SHG coupled-mode equations:
- With AOP $\chi^{(2)}$ grating \rightarrow effective mismatch [2]

$$\chi_{\text{eff}}^{(2)}(z, t) = 3\chi^{(3)}E_{\text{sc}}(z, t)$$

$$g \propto \frac{\chi_{\text{eff}}^{(2)}}{\sqrt{A_{\text{eff},\omega}^2 A_{\text{eff},2\omega}}}$$

$$\Delta k_{\text{eff}} = \Delta k - K_G$$

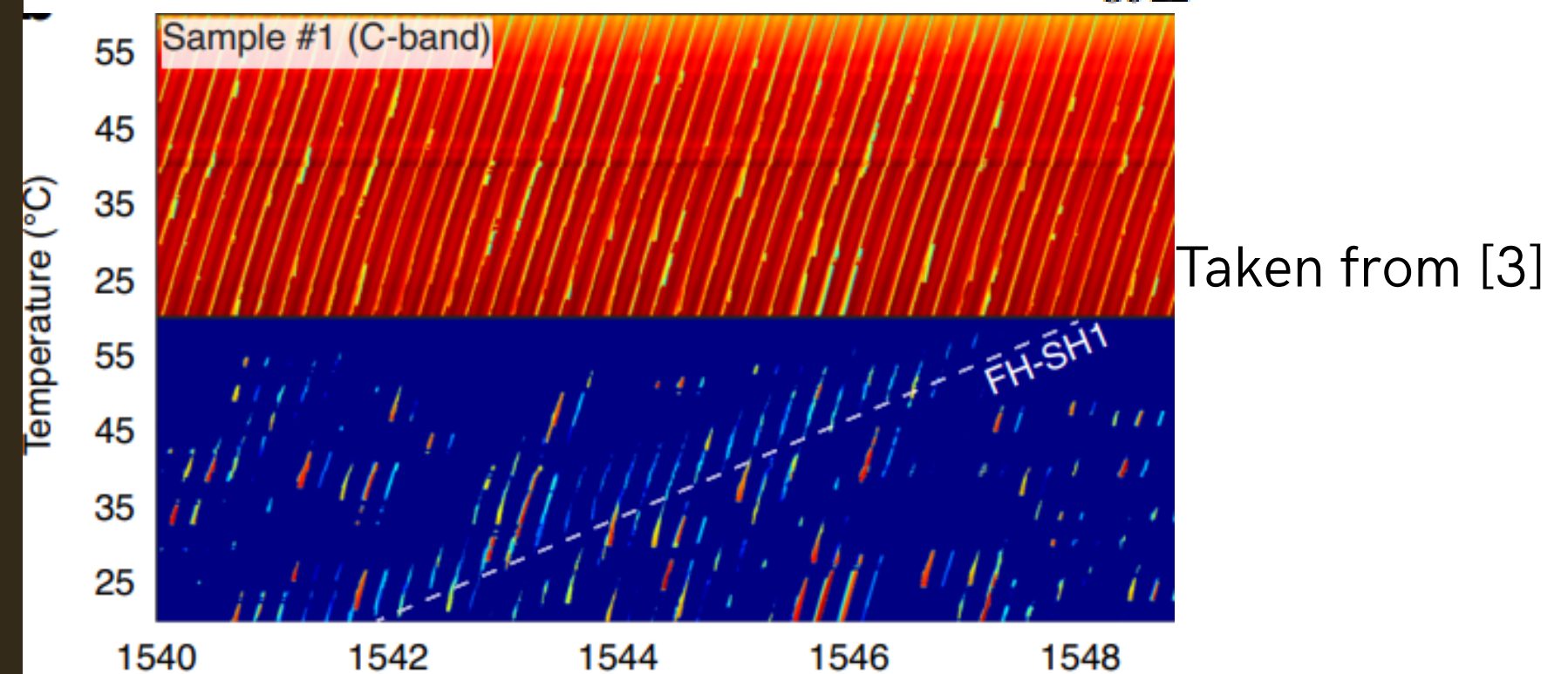
[1] Dianov & Starodubov 1995, Quantum Electron

[2] Nitiss et al. 2019, ACS Photonics

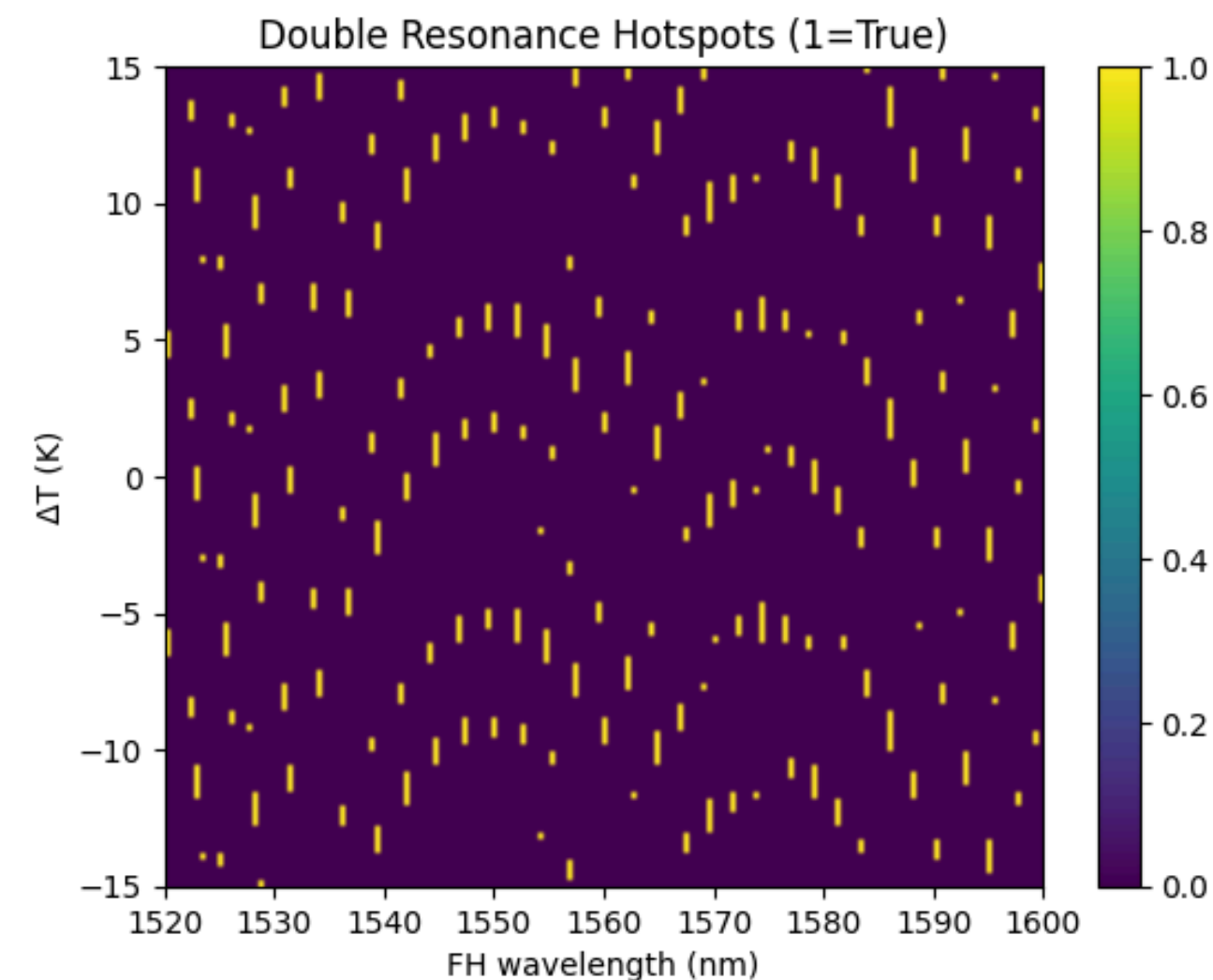
TEMPERATURE TUNING

- **Linear Thermo-Optic tuning:**
 - FH and SH resonances move differently with temperature
 - Double resonance requires both to overlap \rightarrow temperature scanning required: $(\lambda, \Delta T)$ hotspot map.
 - Each vertical streak corresponds to a resonant mode pair $(w, 2w)$.

$$n_{\text{eff}}(T) = n_{\text{eff}}(T_0) + \frac{dn}{dT}(T - T_0)$$



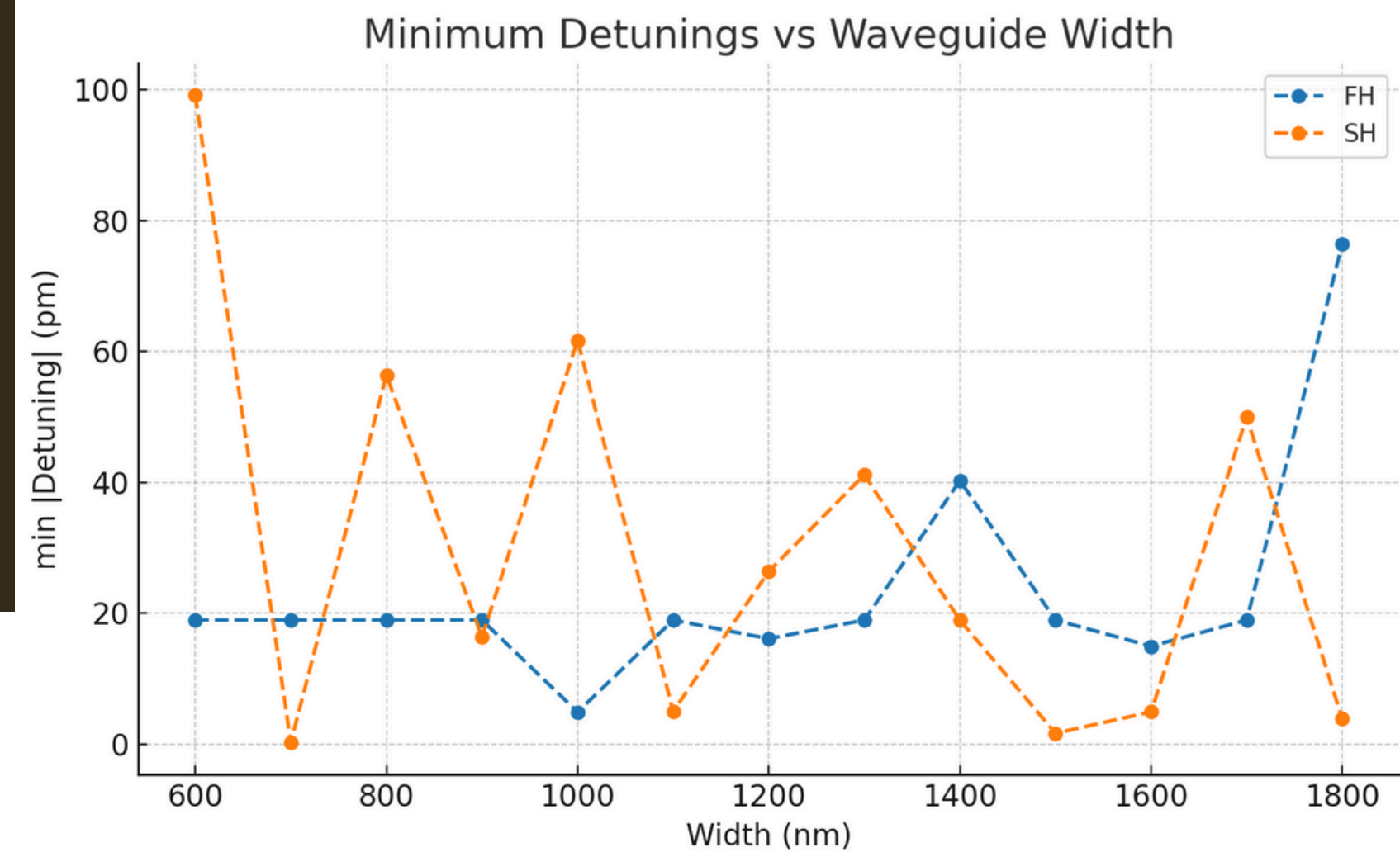
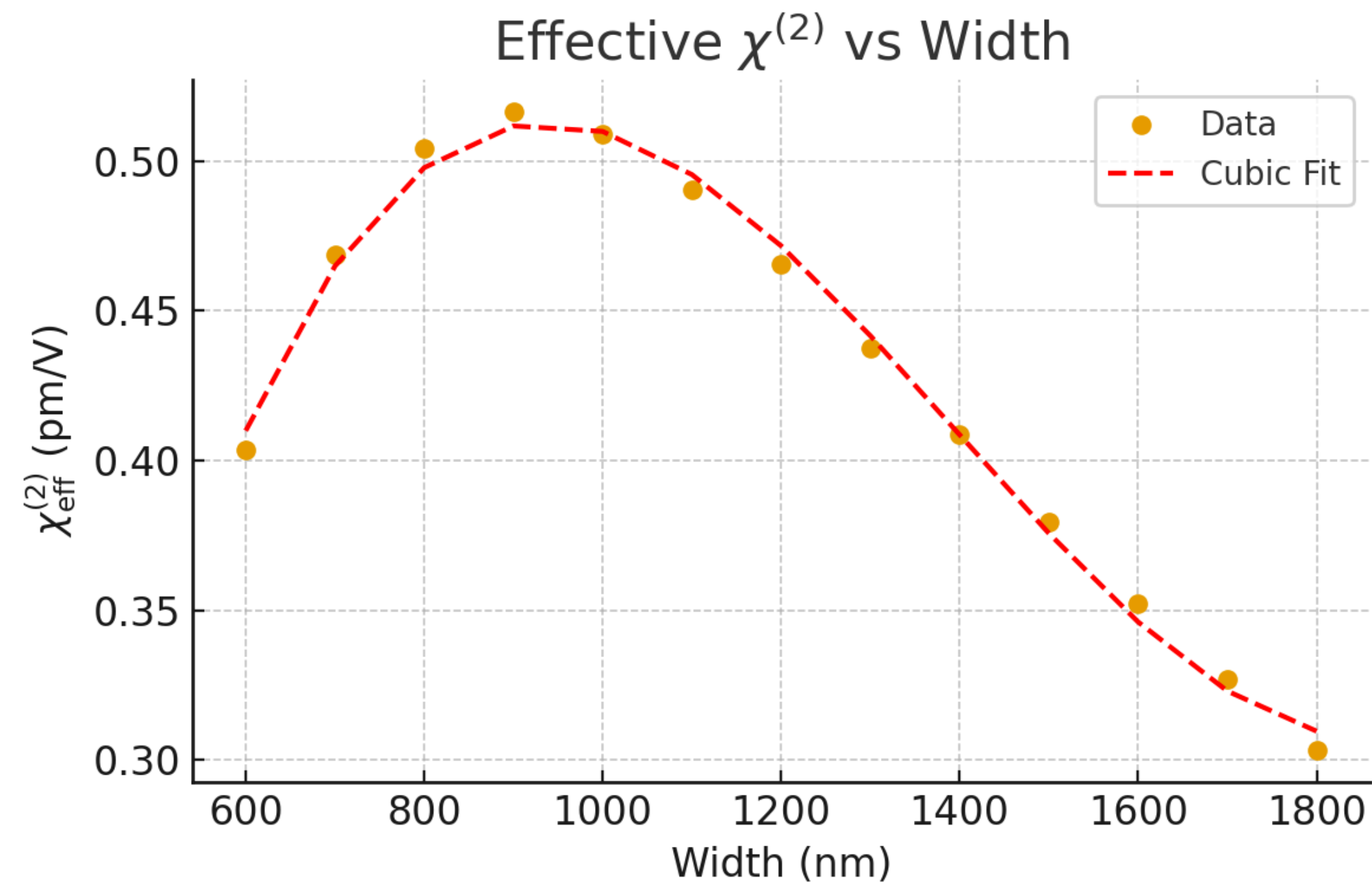
**Double
resonance
exploration**



[3] Clementi et al. (2023). Chip-scale SHG via self-injection-locked all-optical poling. Light: Sci. Appl..

SHG PERFORMANCE

Minimum detuning enhances double resonance



Maximum spot at 900nm width:

$$\chi^2 = 0.516 \text{ pm/V}$$

$$R^2 = 0.995$$

SHG PERFORMANCE

- χ^2 grows gradually as the photogalvanic field builds up.
- Saturates after a few seconds: steady χ^2 available for SHG.

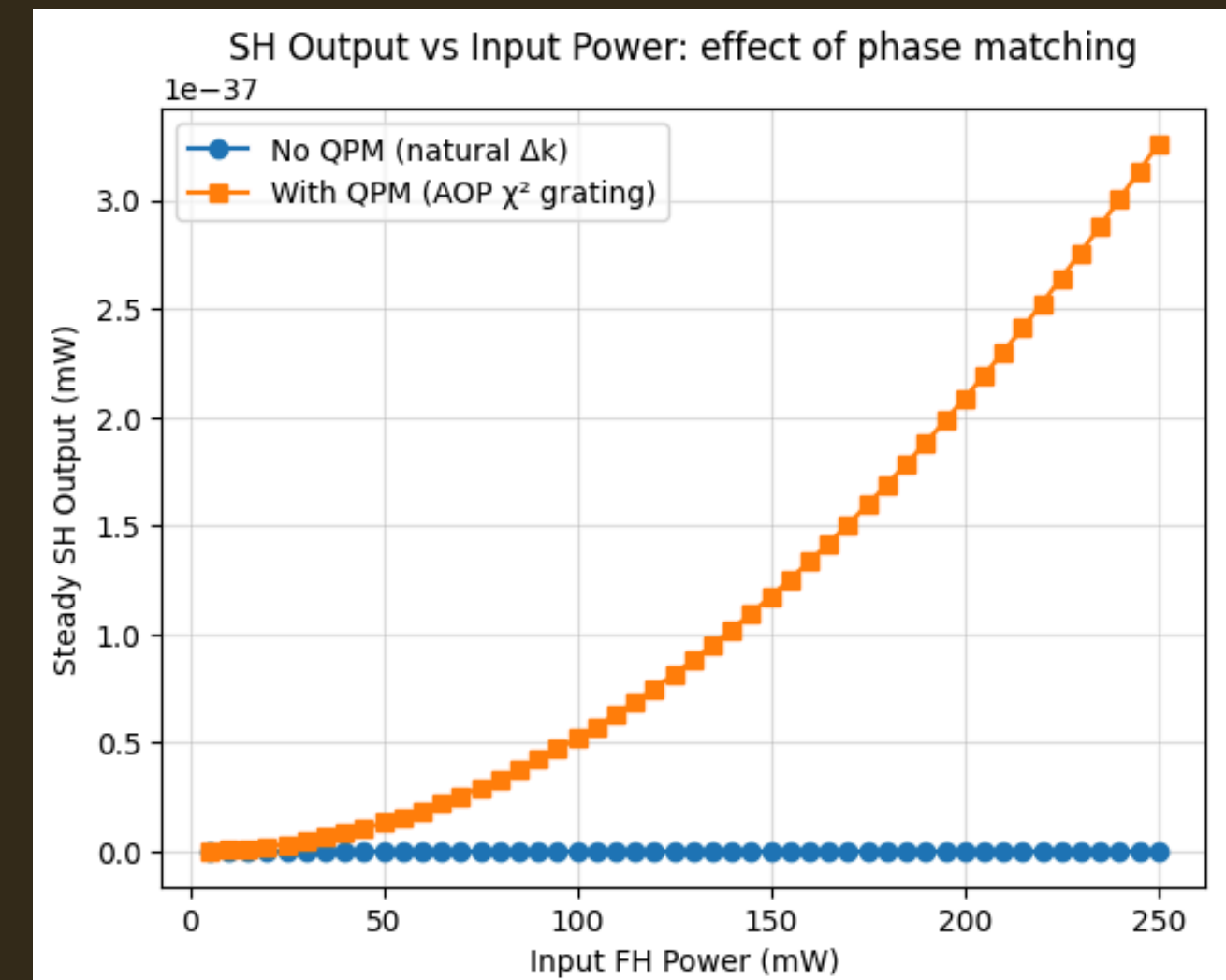
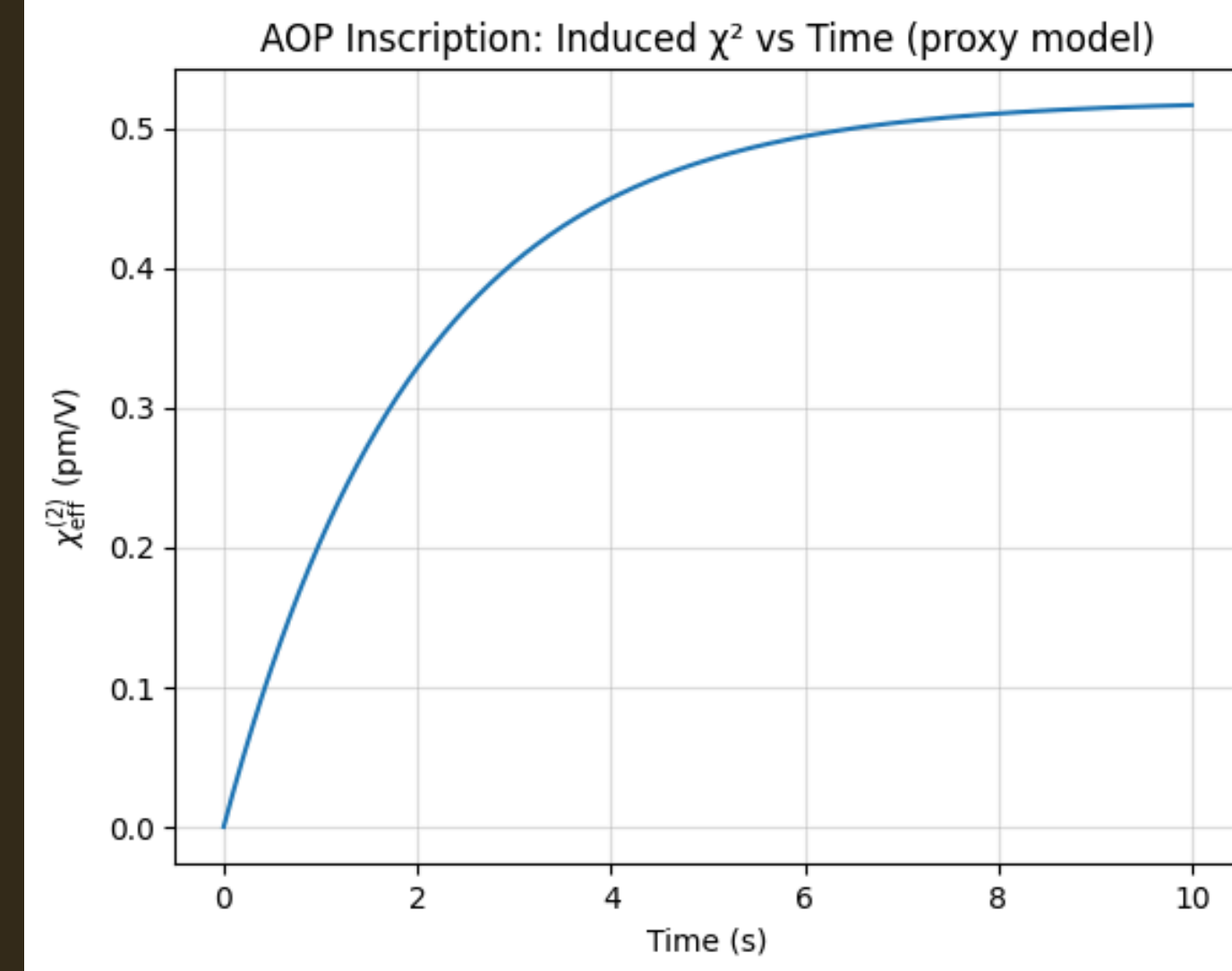


$$\chi^2 = 0.516 \text{ pm/V}$$

- With AOP grating (orange): phase mismatch is compensated.
- SH power grows rapidly and reaches a finite steady level.



$$P = 3.6 \times 10^{-37} \text{ mW}$$



OUTCOMES AND LIMITATIONS

OUTCOMES:

- Extracted $\Delta k(\lambda)$ and $\Lambda(\lambda)$ from Si_3N_4 cross-section
- Exploration of the double resonance hotspots and min detuning
- Demonstrated SHG performance with χ^2 from simulated AOP, finding a maximum value:

$$\chi^2 = 0.516 \text{ pm/V}$$

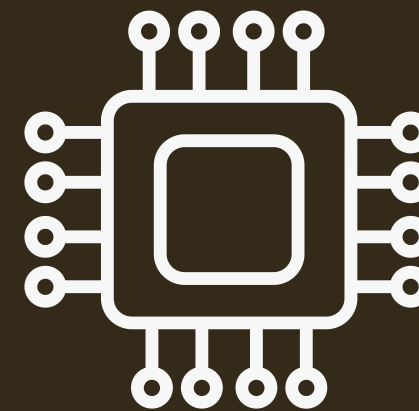
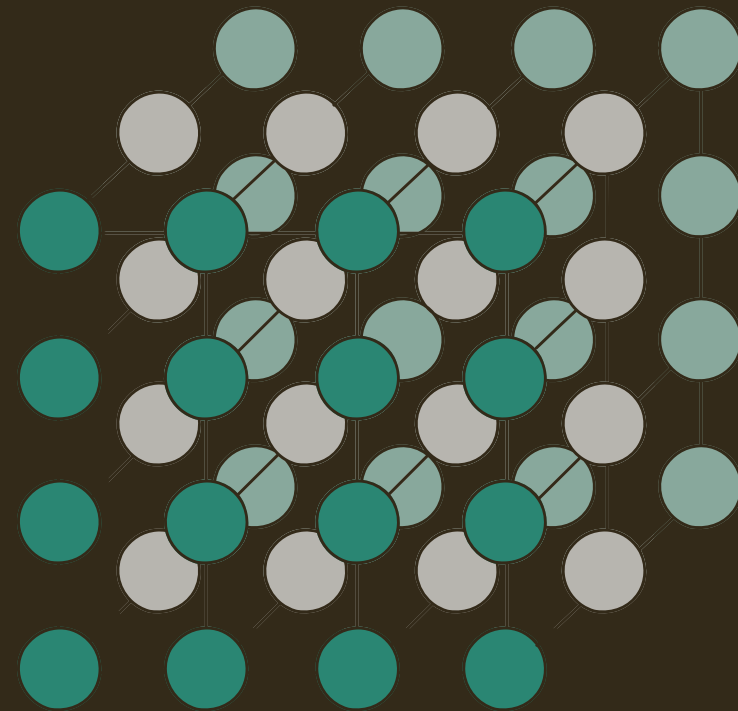
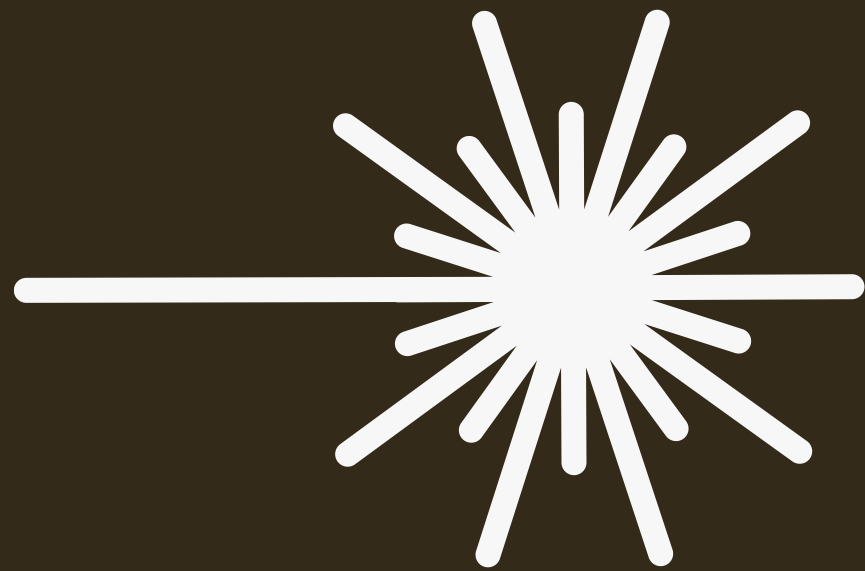
LIMITATIONS:

- No full 3D ring modes (using straight-waveguide approx)
- Only one geometry fully explored
- Low performance compared with other platforms as Lithium Niobate:

$$\chi^2_{\text{LN}} = 54 \text{ pm/V}$$

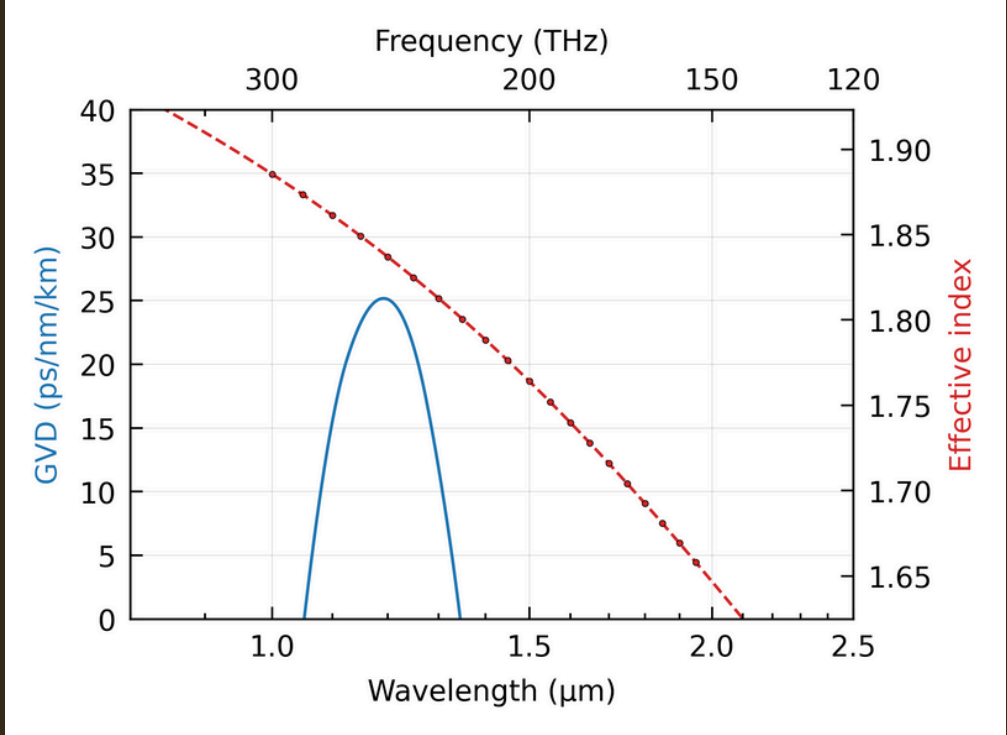
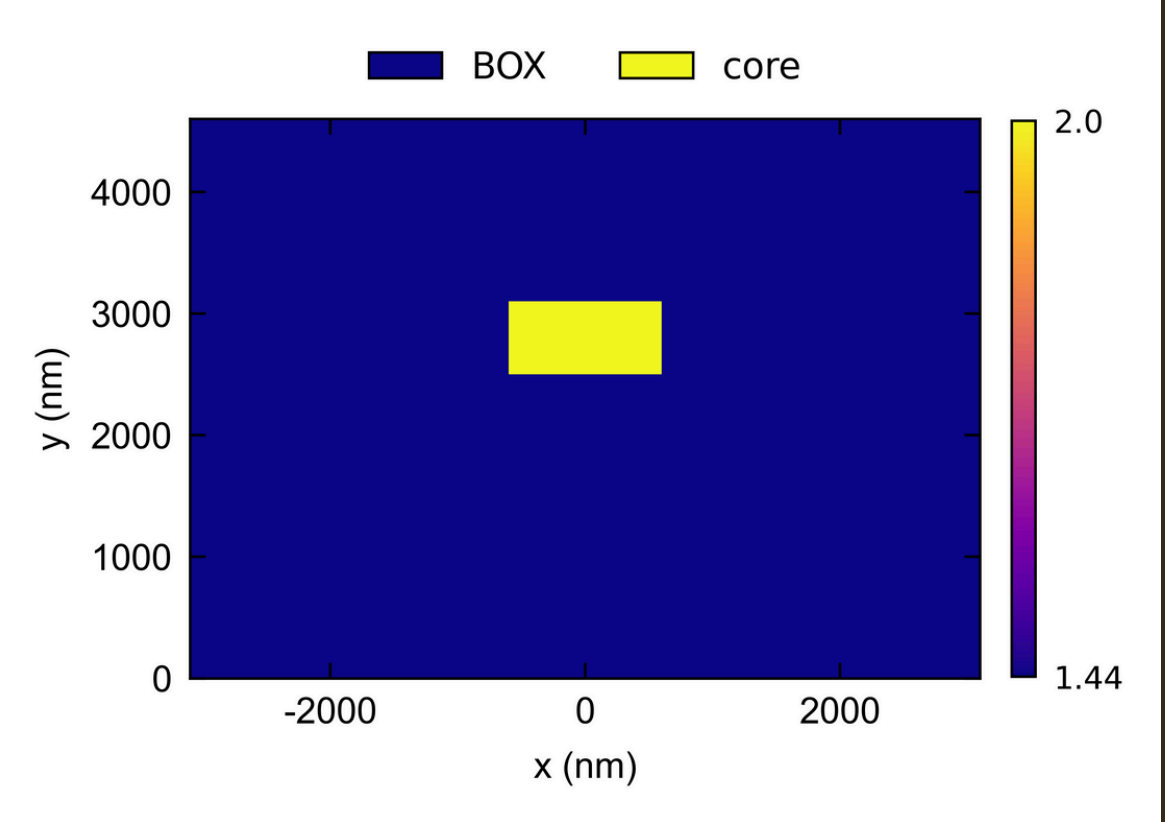
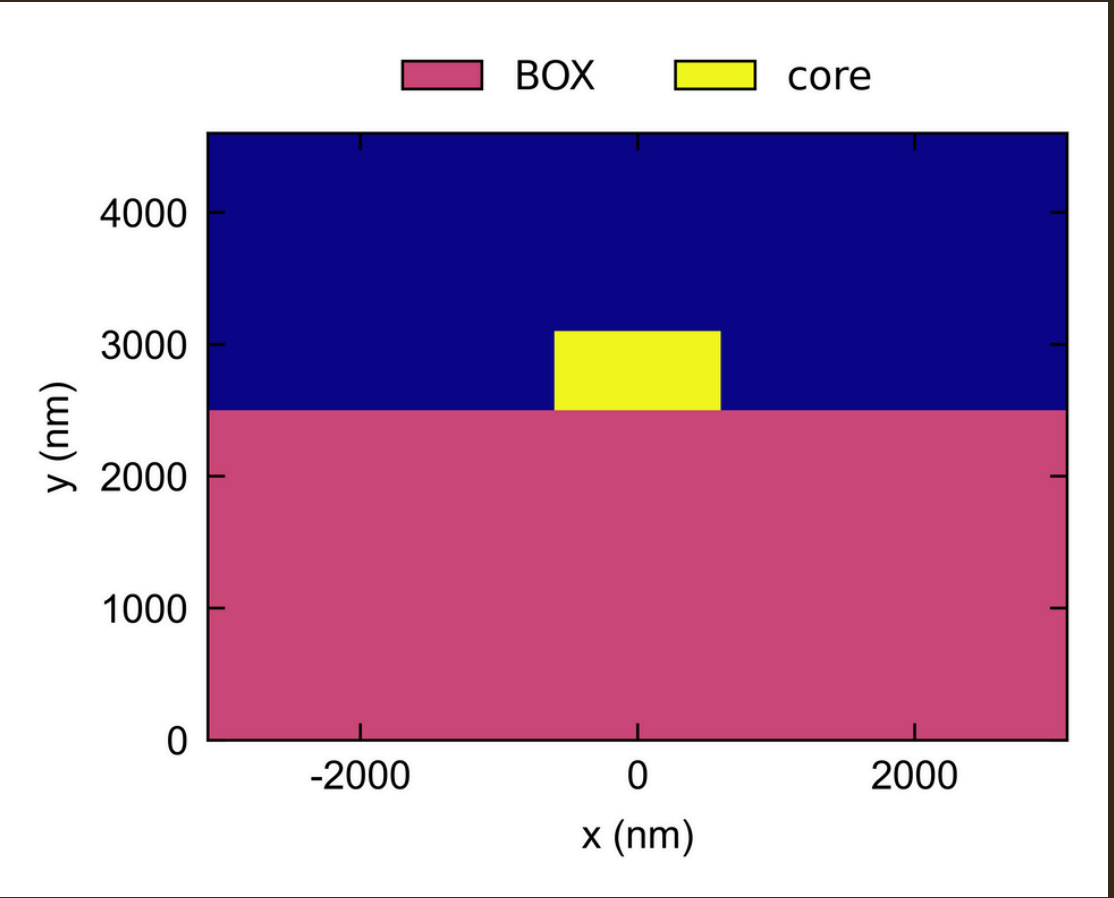
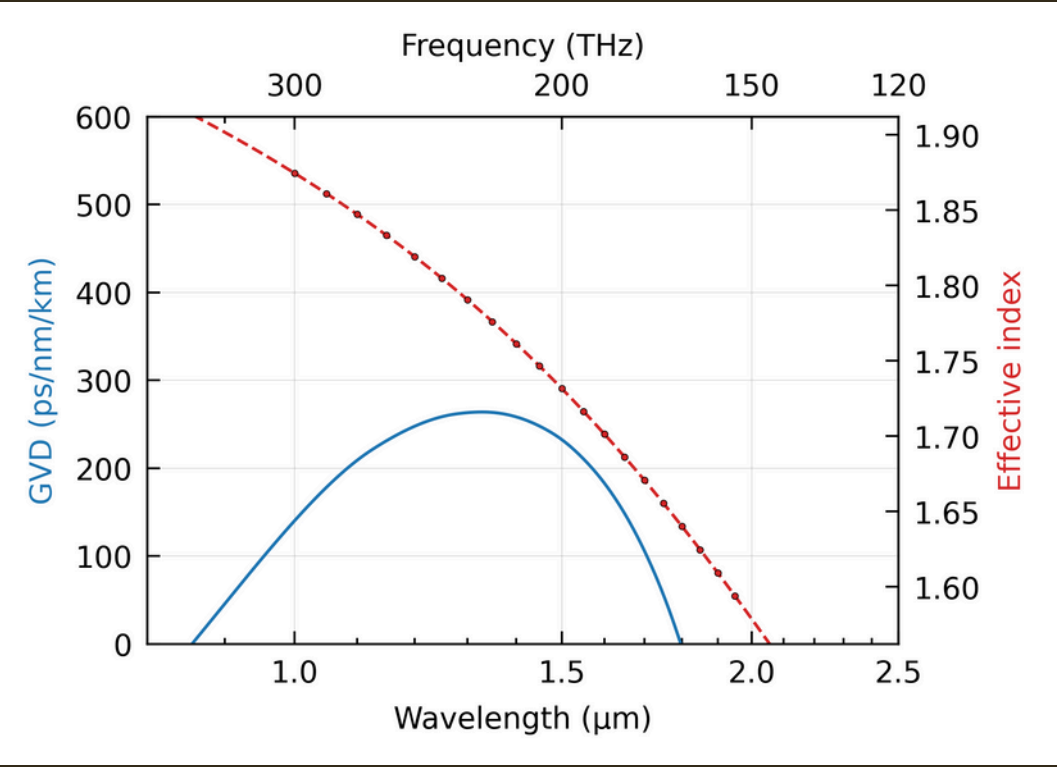
CONCLUSIONS

- AOP enables $\chi(2)$ and improves double-resonance in Si_3N_4 .
- EMode simulated data ($\Delta k, \Lambda$) gives a clear design guidance.
- Hotspot maps show how poling enhances the usable bandwidth.
- Framework ready to explore more geometry sweeps and experimental comparison.



THANKS

APPENDIX



APPENDIX

$$n(\lambda) = \sqrt{1 + \frac{3.0249}{1 - (0.135341/\lambda)^2} + \frac{40314}{1 - (1239.84/\lambda)^2}}$$

Wavelength range: 310 nm to 5504 nm

K. Luke, Y. Okawachi, M. R. E. Lamont, A. L. Gaeta, and M. Lipson, "Broadband mid-infrared frequency comb generation in a Si₃N₄ microresonator," Opt. Lett. 40, 4823 (2015).

APPENDIX: MODE SIMULATIONS

1. Extracted effective refractive indices using EMode:

- $n_{\omega}(\lambda)$
- $n_{2\omega}(\lambda/2)$

2. Compute propagation constants

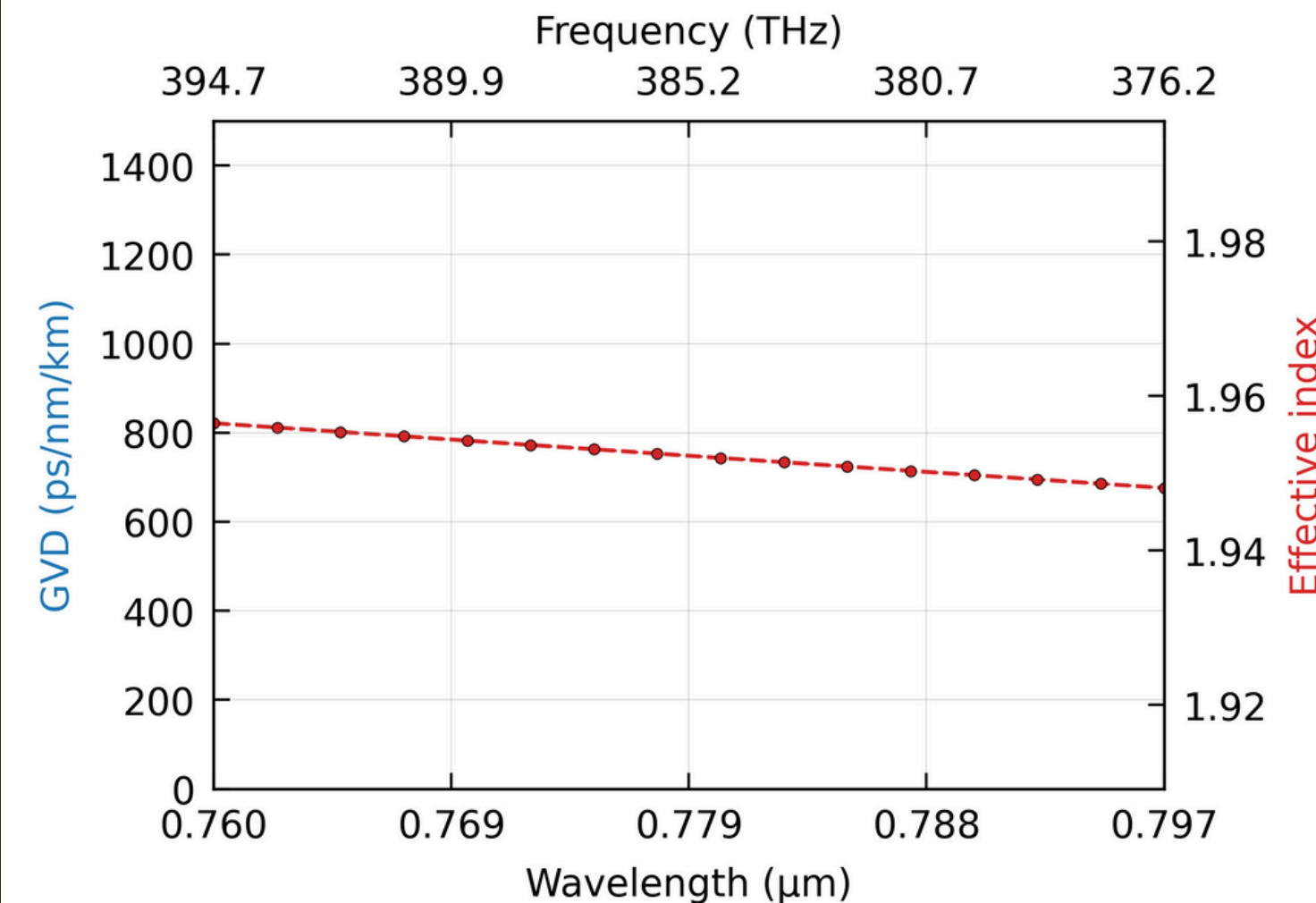
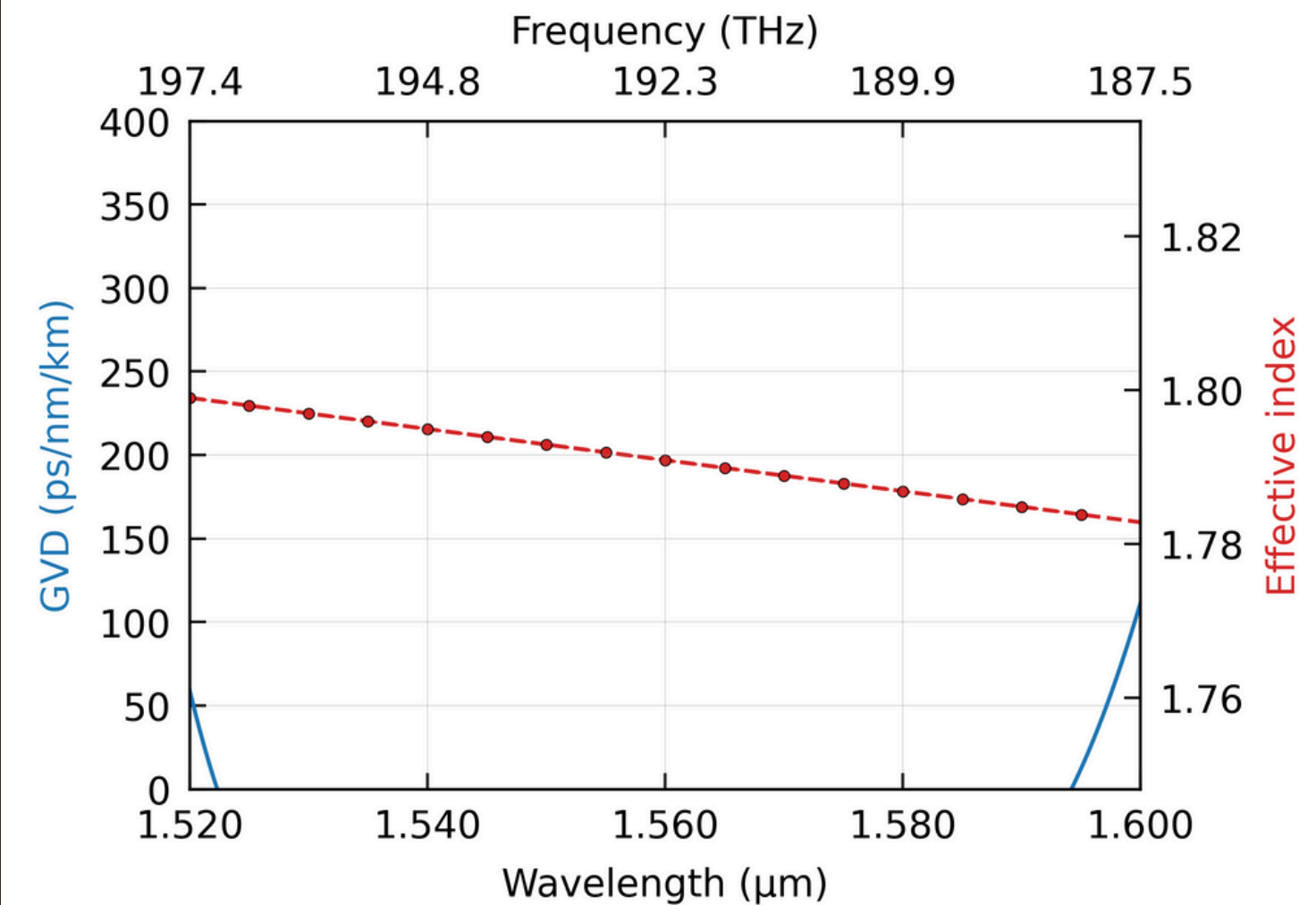
- $\beta = 2\pi n / \lambda$

3. Compute phase mismatch

- $\Delta k = \beta(2\omega) - 2\beta(\omega)$

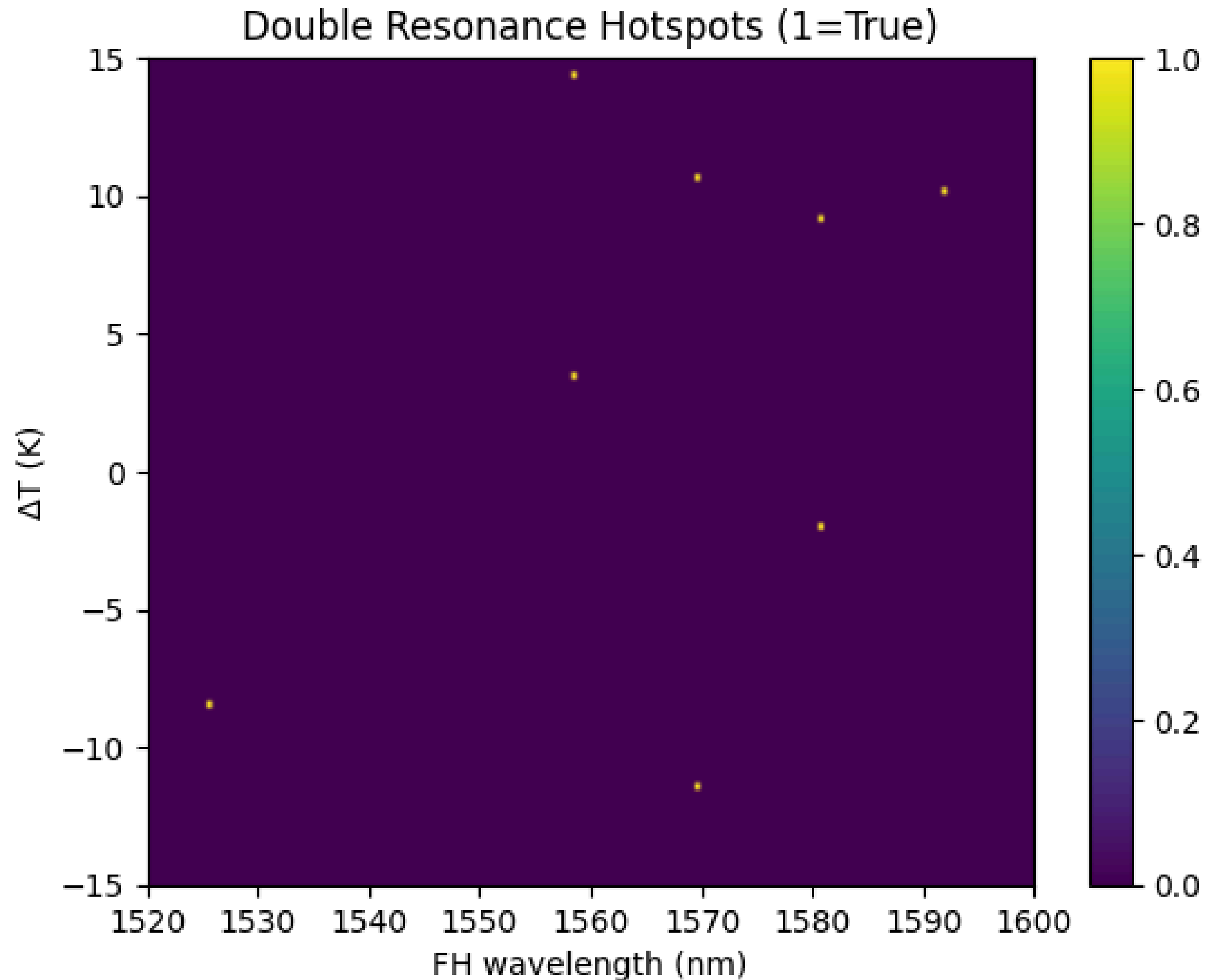
4. Compute QPM period

- $\Lambda = 2\pi / |\Delta k|$



APPENDIX

Almost no
double-resonant
hot-spots with a
1pm detuning



APPENDIX Cubic fit for the effective χ^2

$$\chi_{\text{eff}}^{(2)}(x) = \left(5.30 \times 10^{-10} \frac{\text{pm}}{\text{V} \cdot \text{nm}^3}\right) x^3 - \left(2.22 \times 10^{-6} \frac{\text{pm}}{\text{V} \cdot \text{nm}^2}\right) x^2 + \left(2.76 \times 10^{-3} \frac{\text{pm}}{\text{V} \cdot \text{nm}}\right) x - 0.562 \frac{\text{pm}}{\text{V}}$$

With x the waveguide width in nm, and a Pearson coefficient $R^2 = 0.995$.

APPENDIX: Theoretical Model

For a microring of circumference $L = 2\pi R$, the resonance condition for a given mode is

$$m\lambda = n_{\text{eff}}(\lambda)L$$

Each resonance is characterized by a quality factor Q that can be decomposed into intrinsic (Q_{int}) and coupling (Q_{cpl}) contributions,

$$\frac{1}{Q_{\text{loaded}}} = \frac{1}{Q_{\text{int}}} + \frac{1}{Q_{\text{cpl}}}. \quad (12)$$

The (power) decay rate at angular frequency ω is

$$\kappa = \frac{\omega}{Q_{\text{loaded}}}, \quad (13)$$

with intrinsic and coupling components κ_{int} and κ_{ex} defined analogously. These rates are used in the time-domain coupled-mode equations for the intracavity fields.

We adopt a phenomenological rate equation for the average space-charge field $E(t)$:

$$\frac{dE}{dt} = A_{\text{CPG}} I_{\omega} I_{2\omega} - \frac{E}{\tau_{\text{erase}}},$$

We model the intracavity FH and SH fields by slowly varying complex amplitudes $a(t)$ and $b(t)$, normalized such that $|a|^2$ and $|b|^2$ are proportional to the intracavity powers. The coupled-mode equations for a doubly resonant $\chi^{(2)}$ cavity are

$$\dot{a} = \left(i\Delta_{\omega} - \frac{\kappa_{\omega}}{2} \right) a + ig ba^* + \sqrt{\kappa_{\omega,\text{ex}}} s_{\text{in}}, \quad (19a)$$

$$\dot{b} = \left(i\Delta_{2\omega} - \frac{\kappa_{2\omega}}{2} \right) b + ig a^2, \quad (19b)$$